



Attorney Docket No. 54008.8033.US00
P03-0004

IFL

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Eric J. BERGMAN

APPLICATION No.: 10/631,376

FILED: JULY 30, 2003

FOR: **METHODS OF THINNING A SILICON WAFER USING
HF AND OZONE**

EXAMINER: Z. EL ARINI

ART UNIT: 1746

CONF. NO: 2135

AMENDMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the Office Action mailed on November 22, 2004, please amend the application as follows:

Remarks begin on page 3. Amendments to the claims begin on page 6.

[Continued on Next Page.]

Certificate of Mailing

I hereby certify that this paper (along with any referred to as being attached or enclosed) is being deposited with the United States Postal Service on the date shown below with sufficient postage in an envelope addressed to Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

January 25, 2005
Date of Deposit

Debbie Gilbert
Debbie Gilbert